# **Technical Newsletter**

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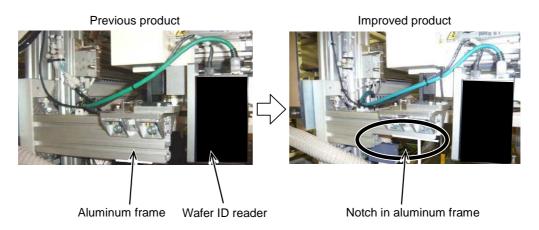
## DFM2800: Presentation of Static-Reducing Frame for Wafer ID Reader

#### Introduction

This document presents an improved aluminum frame for securing the wafer ID reader. The wafer ID reader is a unit installed in the Vision system [optional accessory].

#### Regarding the improved aluminum frame

A notch has been added to the aluminum frame, whose design makes it difficult for air blown from the ionizer to the peeling table section to be obstructed. This may be expected to have the effect of reducing static on the workpiece that occurs during tape peeling. The improved product is installed on machines manufactured from June 2013 onward.



### Handling replacement of frame with improved product

- If you would like to install an improved frame on a machine which has the previous aluminum frame installed in it, we will perform this installation <u>for a fee</u>.
- The improved frames are interchangeable with the previous products in terms of installation. Wafer ID reader <u>height adjustment is required</u> during replacement.

#### Inquiries

Please contact your local DISCO sales representative or customer engineer if you have any questions regarding this matter.